

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant | : | Shimizu, et al. |
| Appl. No. | : | 10/618,900 |
| Filed | : | July 14, 2003 |
| For | : | SINGLE-WAFER-PROCESSING TYPE CVD APPARATUS |
| Examiner | : | Rudy Zervigon |
| Group Art Unit | : | 1763 |

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is an Amendment to the above-identified application in which a request for continued examination (RCE) has been filed herewith under 37 C.F.R. § 1.114(a) in response to the Final Office action mailed October 22, 2007. Please amend the application as follows and reconsider the present application in light of the amendments and the following remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.